



AF/2811

**AFTER FINAL RESPONSE  
RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE REQUESTED  
EXAMINING GROUP 2811**

**PATENT**  
Customer No. 22,852  
Attorney Docket No. 08038.0024

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: )  
)  
Noriaki FUKIAGE ) Group Art Unit: 2811  
)  
Serial No.: 09/657,055 ) Examiner: H. Vu  
)  
Filed: September 7, 2000 )  
)  
For: SEMICONDUCTOR DEVICE HAVING )  
MULTILAYER INTERCONNECTION )  
STRUCTURE AND METHOD OF )  
MAKING THE SAME )

**Mail Stop: AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT AFTER FINAL**

In reply to the final Office Action of November 4, 2003, and pursuant to 37 C.F.R. § 1.116, Applicant proposes that this application be amended as follows:

**Amendments to the Claims** are reflected in the listing of claims in this paper.

**Remarks** follow the amendment section of this paper.

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